

PROCEEDINGS OF SPIE

Optical Components and Materials V

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Editors

21–23 January 2008

San Jose, California, USA

Sponsored and Published by

SPIE

Volume 6890

Proceedings of SPIE, 0277-786X, v. 6890

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

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Author(s), "Title of Paper," in *Optical Components and Materials V*, edited by Michel J. F. Digonnet, Shihbin Jiang, John W. Glesener, J. Christopher Dries, Proceedings of SPIE Vol. 6890 (SPIE, Bellingham, WA, 2008) Article CID Number.

ISSN 0277-786X
ISBN 9780819470652

Published by
SPIE
P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445
SPIE.org

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Printed in the United States of America.

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